

Notice of References Cited

Application/Control No.

10/743,379

Applicant(s)/Patent Under

Reexamination

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Examiner

Russell J. Kemmerle III

Art Unit

1731

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,290,984 A	09-1981	Gaffney, LeRoy J.	264/30
*	B	US-5,616,294 A	04-1997	Deckard, Carl R.	264/413
*	C	US-5,702,501 A	12-1997	Osawa et al.	75/255
*	D	US-2004/0152581 A1	08-2004	Bardes et al.	501/095.2
*	E	US-2004/0262821 A1	12-2004	Odaka, Fumio	264/682
*	F	US-2005/0029711 A1	02-2005	Abe et al.	264/497
*	G	US-2006/0145381 A1	07-2006	Larsson, Morgan	264/040.6
*	H	US-6,155,331	12-2000	Langer et al.	164/456
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Vail et al., "Ceramic structures by Selective Laser Sintering of Microencapsulated, Finely Divided Ceramic Materials", Solid Freeform Fabrication Symposium Proceeding, Univ. of Texas (1992), pp 124-130
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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